U.S. **UTILITY** Patent Application

	O.I.P.E.	PATENT DATE
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SCANNED NSO Q.A.		

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/755516		438 1 B	715	1763	L MOORE

APPLICANTS

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Best Fit?

TITLE

Apparatus having platform positioned for precise centering of semiconductor wafers during processing

PTO-2040
12/99

JC5/1020

ISSUING CLASSIFICATION

ORIGINAL		CROSS REFERENCE(S)					
CLASS	SUBCLASS	CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)				
INTERNATIONAL CLASSIFICATION							

☐ Continued on Issue Slip Inside File Jacket

TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.

☐ The term of this patent subsequent to _____ (date) has been disclaimed.

(Assistant Examiner) _____ (Date)

NOTICE OF ALLOWANCE MAILED

☐ The term of this patent shall not extend beyond the expiration date of U.S. Patent. No. _____

(Primary Examiner) _____ (Date)

ISSUE FEE

Amount Due	Date Paid

☐ The terminal _____ months of this patent have been disclaimed.

(Legal Instruments Examiner) _____ (Date)

ISSUE BATCH NUMBER

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